## RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE GROUP ART UNIT 3729

Docket Number 36856.1439

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Takayuki TSUKIZAWA et al.

Application No.: 10/596,312

Confirmation No.: 5223

Filing or 371(c) Date: June 8, 2006

Title: METHOD FOR MANUFACTURING CHIP ELECTRONIC COMPONENT-MOUNTED CERAMIC SUBSTRATE Art Unit: 3729

Examiner: T. Phan

## REQUEST FOR RECONSIDERATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 20, 2009, please reconsider the above-identified application in view of the following remarks.

**Listing of the Claims** begins on page **2**. No amendments have been made to the Claims.

Remarks/Arguments begin on page 5 of this paper.